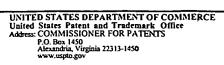


# United States Patent and Trademark Office



APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/691,155	10/19/2000	Robert A. Hoffman	₽-4744	4567
7590 12/15/2003		EXAMINER '		
Richard J. Rodrick, Esq.			GEISEL, KARA E	
Becton Dickin	son and Company			
1 Becton Drive			ART UNIT	PAPER NUMBER
Franklin Lakes, NJ 07417-1880			2877	

DATE MAILED: 12/15/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)			
Office Action Summary		09/691,155	HOFFMAN ET AL.			
		Examiner	Art Unit			
	•	Kara E Geisel	2877			
	The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).  Status						
1)🛛	Responsive to communication(s) filed on 20 N	lovember 2003.				
2a) <u></u> □	This action is <b>FINAL</b> . 2b)⊠ This	action is non-final.				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4)🖾	4) Claim(s) <u>1-4,7-12,17,18 and 21-51</u> is/are pending in the application.					
	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)🔯	5) Claim(s) 26 and 41 is/are allowed.					
6)⊠	6)⊠ Claim(s) <u>1-4,7-12,14-18,21-25,27-40 and 42-51</u> is/are rejected.					
7)	7) Claim(s) is/are objected to.					
8)[	8) Claim(s) are subject to restriction and/or election requirement.					
Applicati	on Papers					
9) 🗌 🤈	The specification is objected to by the Examine	er.				
10)	10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					
	Applicant may not request that any objection to the	drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).			
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. §§ 119 and 120						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:  1. Certified copies of the priority documents have been received.  2. Certified copies of the priority documents have been received in Application No.  3. Copies of the certified copies of the priority documents have been received in this National Stage						
application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.  13) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet.  37 CFR 1.78.  a) The translation of the foreign language provisional application has been received.  14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific						
reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.						
Attachment(s)						
2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s) _	5) D Notice of Informal P	(PTO-413) Paper No(s) atent Application (PTO-152)			

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### **DETAILED ACTION**

#### Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's amendment filed on October 9<sup>th</sup>, 2003 has been entered.

# Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary.

Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-3, 7-10, 15-17, 21-24, 27, and 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto et al. (USPN 5,563,070), previously cited, in view of Kusuzawa (USPN 5,596,401) previously cited, and further in view of Noller (USPN 4,857,735), newly cited.

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In regards to claims 1, 7-10, 15, and 21-24, Yamamoto discloses an apparatus for examining a particle in a flow stream of a flow cytometer (fig. 13) comprising a light emitting device (fig. 13, 15) comprising one incoherent light emitting semiconductor device (column 6, lines 52-55 and 58-61; column 8, lines 21-23) adapted to emit light toward the flow stream (column 9, lines 50-53), and a detector (fig. 13, 17) adapted to detect light emanating from the particle in response to emitted light striking the particle (column 9, lines 50-53). Yamamoto does not disclose a second system for detecting the particle so that the first system can analyze the particle. However, this is well known in the art, and it would have been obvious to a person of ordinary skill in the art to add a second detection system in order to detect the particle, and control the first light source to image the particle once it has been detected.

For example, Kusuzawa discloses an apparatus for examining a particle in a flow stream of a flow cytometer. The apparatus includes a controller (fig. 1, 26) adapted to control the light-emitting device to emit light for a predetermined period, during which the emitted light radiates on the particle (column 8, lines 8-13). This controller is adapted to control the light-emitting device to emit light in pulses (column 5, lines 11-18). The apparatus further includes a second substantially coherent light-emitting device adapted to emit its light towards the flow stream (fig. 1, 8), which is a laser (column 7, lines 56-67 and column 8, lines 1-13). There is a second detector (fig. 1, 20 and 22) adapted to detect the second light emanating from the particle in response to the second emitted light striking the particle (column 7, 62-67). The controller is adapted to control the first light emitting device based on the detection of the second emanating light by the second detector (column 8, lines 8-17).

Neither reference teaches controlling the light-emitting device to emit light having a duty cycle less than about 10%, and such that a light intensity of the light emanating from the device during the pulses is greater than that which could be maintained in continuous mode. However, it is very well known in the art to control a light-emitting device to have a duty cycle less than 10% with pulses having a

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higher intensity than could be maintained in continuous mode in order to increase the life of the device while still allowing the device to emit light at a sufficient intensity.

For example, Noller teaches pulsing a LED with a duty cycle of less than 10% with pulses having a higher intensity than could be maintained in continuous mode (column 2, lines 1-17). This is done in order to insure that the LED will emit with a sufficient intensity while keeping the LED from burning out. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to pulse the light-emitting device of the combined system with a duty cycle less than about 10% with pulses having a higher intensity than could be maintained in continuous mode in order to increase the life of the device while still allowing the device to emit light at a sufficient intensity.

In regards to claims 2, 16, 27, and 29 the apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. Furthermore, the incoherent light emitting semiconductor device (Yamamoto fig. 13, 15) is a light emitting diode (Yamamoto column 6 lines 52-61 and column 8, lines 21-23).

In regards to claims 3 and 17, the apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. Furthermore, the emanating light comprises fluorescent light and the detector is adapted to detect fluorescent light (Yamamoto column 9, lines 46-55).

Claims 4, 18, 28 and 30 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto et al. (USPN 5,563,070) previously cited, in view of Kusuzawa (USPN 5,596,401), previously cited, further in view of Noller (USPN 4,857,735), newly cited, as applied to claims 1-3, 7-10, 15-17, 21-24, 27, and 29 above, and further in view of Unterleitner (UPSN 4,498,766), previously cited.

In regards to claims 4 and 18, the combined apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. The combined system does not disclose two incoherent light emitting semiconductor devices.

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Unterleitner discloses a flow cytometer with two exciting light sources (fig. 1, 14 and 12), which may be incoherent (column 4, lines 2-6). Two incoherent exciting light sources of different wavelengths are used so that it is possible to detect and monitor two different types of particles having different fluorescent characteristics (column 3, lines 42-65). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to add another incoherent light emitting semiconductor device with a respective light emission to Yamamoto's flow cytometer and furthermore adapt the detectors to detect each light emanating from a particle in response to each emitted light in order to detect and monitor two different types of fluorescing particles.

In regards to claims 28 and 30, apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. The combined system does not disclose having the LED emit light in the ultraviolet range. However, it is well known in the art that some markers need UV light to fluoresce, and it would be obvious to one of ordinary skill at the time the invention was made to use an ultraviolet LED in order to fluoresce these markers.

For example, Unterleitner discloses using an ultraviolet light source, which could be an incoherent light source such as an LED, in a flow cytometry apparatus in order to excite fluorochromes to fluoresce (columns 3-4, lines 58-68 and 1-6, respectively). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have the LED emit ultraviolet light in order to be able to use a fluorochrome that excites by UV radiation.

Claims 11-12, 14, and 25 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yamamoto et al. (USPN 5,563,070) previously cited, in view of Kusuzawa (USPN 5,596,401), previously cited, further in view of Noller (USPN 4,857,735), newly cited, as applied to claims 1-3, 7-10, 15-17, 21-24, 27, and 29 above, and further in view of Hoffman et al. (UPSN 5,528,045), previously cited.

In regards to claims 11-12 and 25, the combined apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. The combined system does not disclose a light-

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obstructing device with two transparent portions to allow portions of the emanating light from a particle to be detected.

Hoffman discloses an apparatus for detecting particles in a flow cytometer. The particles are tagged with multiple fluorochromes, which are excited at different locations in a flow cell by different excitation sources. A light-obstructing device (fig. 1, SPF), having a substantially opaque portion and two substantially transparent portions (Fig. 1, AP1 and AP2), is placed before a detector so that the emanating light from each fluorochrome attached to the particle can be discriminated and detected separately (column 2, lines 49-67). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to add a light obstructing device with two substantially transparent portions into Yamamoto's apparatus in order to detect light from two different fluorochromes attached to a particle.

In regards to claim 14, combining a light-obstructing device with an apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. Furthermore, the light-obstructing device is located at an image plane (Hoffman column 3, lines 1-5).

Claims 31-33 and 43-45 are rejected under 35 U.S.C. 103(a) as being unpatentable over Zarling et al. (USPN 5,674,698), previously cited, in view of Noller (USPN 4,857,735), newly cited.

In regards to claims 31 and 43, Zarling discloses an apparatus that can be used for examining a particle in a flow stream of a flow cytometer (column 7-8, lines 65-67 and 1-7, respectively) comprising a light emitting device which can comprise at least one light emitting diode (fig. 3, 20(1) and column 33, lines 52-55) adapted to emit light toward a flow stream, a detector (fig. 3, 22(1)) adapted to detect light emanating from said particle (fig. 3, 15) in response to said emitted light striking said particle (column 33, lines 52-67), and a controller (fig. 3, 50) adapted to control said light emitting device to emit light in pulses (column 35, lines 36-41). Zarling does not teach controlling the light-emitting device to emit light such that a light intensity of the light emanating from the device during the pulses is greater than that

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which could be maintained in continuous mode. However, it is very well known in the art to control a light-emitting device to emit pulses having a higher intensity than could be maintained in continuous mode in order to increase the life of the device while still allowing the device to emit light at a sufficient intensity.

For example, Noller teaches pulsing a LED with pulses having a higher intensity than could be maintained in continuous mode (column 2, lines 1-17). This is done in order to insure that the LED will emit with a sufficient intensity while keeping the LED from burning out. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to pulse the light-emitting device of the combined system with pulses having a higher intensity than could be maintained in continuous mode in order to increase the life of the device while still allowing the device to emit light at a sufficient intensity.

In regards to claims 32 and 44, the emanating light comprises fluorescent light and the detector is adapted to detect said fluorescent light (Zarling, column 12, lines 37-54).

In regards to claims 33 and 45, the light emitting device comprises two incoherent light emitting semiconductor devices (Zarling, fig. 1, 20(1) and 20(2)) each adapted to emit a respective light toward said flow stream and the detector (Zarling, fig. 1, 22(1) and 22(2)) is adapted to detect each light emanating from said particle in response to said respective emitted lights (Zarling, column 33, lines 39-67).

Claims 34-38 and 46-50 are rejected under 35 U.S.C. 103(a) as being unpatentable over Zarling et al. (USPN 5,674,698), previously cited, in view of Noller (USPN 4,857,735), newly cited, as applied to claims 31-33 and 43-45 above, and further in view of Kusuzawa (USPN 5,596,401), previously cited.

In regards to claims 34-38 and 46-50, the combined apparatus discloses an apparatus for examining a particle in a flow stream of a flow cytometer as discussed above. The combined apparatus does not disclose a second system for detecting the particle before the particle is analyzed. However, a

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second system for detecting a particle so that the first system can analyze the particle is well known in the art, and it would have been obvious to a person of ordinary skill in the art to add a second detection system in order to detect the particle, and control the first light source to image the particle once it has been detected.

For example, Kusuzawa discloses an apparatus for examining a particle in a flow stream of a flow cytometer. The apparatus includes a controller (fig. 1, 26) adapted to control the light-emitting device to emit light for a predetermined period, during which the emitted light radiates on the particle (column 8, lines 8-13). This controller is adapted to control the light-emitting device to emit light in pulses (column 5, lines 11-18). The apparatus further includes a second substantially coherent light-emitting device adapted to emit its light towards the flow stream (fig. 1, 8), which is a laser (column 7, lines 56-67 and column 8, lines 1-13). There is a second detector (fig. 1, 20 and 22) adapted to detect the second light emanating from the particle in response to the second emitted light striking the particle (column 7, 62-67). The controller is adapted to control the first light emitting device based on the detection of the second emanating light by the second detector (column 8, lines 8-17).

Claims 39-40, 42 and 51 are rejected under 35 U.S.C. 103(a) as being unpatentable over Zarling et al. (USPN 5,674,698), previously cited, in view of Noller (USPN 4,857,735), newly cited, as applied to claims 31-33 and 43-45 above, and further in view of Hoffman et al. (UPSN 5,528,045), previously cited.

In regards to claims 39-40 and 51, the combined apparatus discloses an apparatus for examining a particle in a flow stream of a flow cytometer as discussed above. The combined apparatus does not disclose a light-obstructing device with two transparent portions to allow portions of the emanating light from a particle to be detected.

Hoffman discloses an apparatus for detecting particles in a flow cytometer. The particles are tagged with multiple fluorochromes, which are excited at different locations in a flow cell by different excitation sources. A light-obstructing device (fig. 1, SPF), having a substantially opaque portion and

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two substantially transparent portions (Fig. 1, AP1 and AP2), is placed before a detector so that the emanating light from each fluorochrome attached to the particle can be discriminated and detected separately (column 2, lines 49-67). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to add a light obstructing device with two substantially transparent portions into the combined apparatus in order to detect light from two different fluorochromes attached to a particle.

In regards to claim 42, combining a light-obstructing device with an apparatus for examining a particle in a flow stream of a flow cytometer is discussed above. Furthermore, the light-obstructing device is located at an image plane (Hoffman column 3, lines 1-5).

# Allowable Subject Matter

Claims 26 and 41 are allowed over the prior art of record (see paper number 8).

#### Additional Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

The prior art made of record is Kolber et al. (USPN 6,121,053).

Kolber discloses an apparatus for examining a particle comprising a light emitting device, such as an LED, adapted to emit light towards the particle, a detector adapted to detect light emanating from the particle in response to the emitted light striking the particle, and a controller, adapted to control the light emitting device to emit light in pulses having a duty cycle less than about 10% and such that a light intensity of the light emanating form the light emitting device during the pulses is greater than that which could be maintained in continuous mode.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kara E Geisel whose telephone number is 703 305 7182. The examiner can normally be reached on Monday through Friday, 8am to 4pm.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Frank Font can be reached on 703 308 4881. The fax phone numbers for the organization where this application or proceeding is assigned are 703 872 9306 for regular communications and 703 872 9306 for After Final

communications. For inquiries of a general nature, the Customer Service fax number is 703 872 9317.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 308 1782.

F.L. Evans Primary Examiner Art Unit 2877 Page 10

KEG

December 4, 2003